

WEST Search History

DATE: Wednesday, July 27, 2005

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
	<i>DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L26	91062128	1
	<i>DB=JPAB; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L25	JP-91062128-B.did.	0
	<i>DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L24	63015710	2
<input type="checkbox"/>	L23	6315710	2
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L22	L20 and ((substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5) with (UV or ultraviolet) with ((ozone or 'O.sub.3')))	7
<input type="checkbox"/>	L21	L20 and ((substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5) with (UV or ultraviolet) with ((ozone or 'O.sub.3') adj7 (water or liquid or solution)))	0
<input type="checkbox"/>	L20	dainippon screen	17027
	<i>DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L19	L18 and l8	17
<input type="checkbox"/>	L18	134/902,56R,58R,18,1,33;438/905,906.ccls.	6768
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L17	(substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5) with (UV or ultraviolet) with ((ozone or 'O.sub.3') adj7 (water or liquid or solution))	29
<input type="checkbox"/>	L16	L15 with (rotat\$3 or spin\$3)	10
<input type="checkbox"/>	L15	(substrate or wafer or semiconductor or workpiece) with (clean\$3 or treat\$3 or wash\$3) with (UV or ultraviolet) with ((ozone or 'O.sub.3') adj7 (water or liquid or solution))	69
	<i>DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L14	19 same ((substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5))	1
<input type="checkbox"/>	L13	19 with (substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5)	1
	<i>DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L12	19 with (substrate or wafer or semiconductor or workpiece) with (rotat\$5 or spin\$5)	0
<input type="checkbox"/>	L11	L10 and l8	6
<input type="checkbox"/>	L10	134/902,56R,58R.ccls.	3061

DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

☐ L9 (UV or ultraviolet) with (control\$5 or switch\$3) with power 436

DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ

☐ L8 (UV or ultraviolet) with (control\$5 or switch\$3) with power 1099

DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

☐ L7 (UV or ultraviolet) with (control\$5 or switch\$3) with power 1535

☐ L6 L5 same (ozone or 'O.sub.3') 21

☐ L5 ((substrate or wafer or semiconductor or workpiece) with (clean\$3 or treat\$3 or wash\$3)) same ((UV or ultraviolet) with (control\$5 or switch\$3)) 194

☐ L4 L2 same (ozone or 'O.sub.3') 17

☐ L3 L2 with (ozone or 'O.sub.3') 12

☐ L2 (substrate or wafer or semiconductor or workpiece) with (clean\$3 or treat\$3 or wash\$3) with (UV or ultraviolet) with (control\$5 or switch\$3) 98

☐ L1 (substrate or wafer or semiconductor or workpiece) with (clean\$3 or treat\$3 or wash\$3) with ((UV or ultraviolet) adj 10 (control\$5 or switch\$3)) 0

END OF SEARCH HISTORY